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AMENDMENT TRANSMITTAL LETTER			Docket No. 29926/39487	
Application No. 10/613,331-Conf. #5070	Filing Date July 3, 2003	Examiner Brook Kebede	Art Unit 2823	

Applicant(s): In Haeng Lee et al.

Invention: METHOD FOR FORMING METAL SILICIDE LAYER IN ACTIVE AREA OF SEMICONDUCTOR DEVICE

TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	28	- 31 =	0	x	
Independent Claims	2	- 3 =	0	x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify): Extension for response within second month AND Supplemental Information Disclosure Statement					450.00 180.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					630.00

- ☒ Large Entity ☐ Small Entity
- ☐ No additional fee is required for this amendment.
- ☐ Please charge Deposit Account No. _____ in the amount of \$ _____.
A duplicate copy of this sheet is enclosed.
- ☒ A check in the amount of \$ 630.00 to cover the filing fees is enclosed.
- ☐ Payment by credit card. Form PTO-2038 is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. 13-2855 as described below. A duplicate copy of this sheet is enclosed.
- ☒ Credit any overpayment.
- ☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

Michael R. Hull
Attorney Reg. No.: 35,902

Dated: July 21, 2005

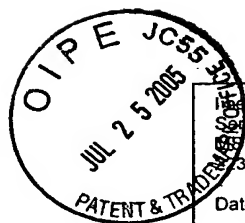
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I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: July 21, 2005

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Signature: _____

(Michael R. Hull)

Docket No.: 29926/39487
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
In Haeng Lee et al.

Application No.: 10/613,331

Confirmation No.: 5070

Filed: July 3, 2003

Art Unit: 2823

For: METHOD FOR FORMING METAL SILICIDE
LAYER IN ACTIVE AREA OF
SEMICONDUCTOR DEVICE

Examiner: Brook Kebede

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated February 23, 2005, please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 9 of this paper.